

**AMENDMENT TRANSMITTAL LETTER**Docket No.
291958171US4Application No.
10/695,419-Conf. #4483Filing Date
October 27, 2003Examiner
T.H. ParsonsArt Unit
1745

Applicant(s): Chen et al.

Invention: APPARATUS AND METHOD FOR ELECTROLYTICALLY DEPOSITING COPPER ON A SEMICONDUCTOR WORKPIECE

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	5	- 30 =	0	x	0.00
Independent Claims	1	- 10 =	0	x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Statutory Disclaimer					130.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					130.00

☒ Large Entity☐ Small Entity☐ No additional fee is required for this amendment.☐ Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.☒ A check in the amount of \$ 130.00 to cover the filing fee is enclosed.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0665
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

Paul T. Parker

Attorney Reg. No.: 38,264

Dated: December 8, 2004

PERKINS COIE LLP

P.O. Box 1247

Seattle, Washington 98111-1247

(206) 359-8000

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as Express Mail, Airbill No. EV528705936US, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: 12/8/04

Signature:

(Melody Almberg)



12-9-04

Attorney Docket No. 291958171US4
Semitool Ref No. P98-0025US8

Ifu
\$

Express Mail Label EV528705936US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: LINLIN CHEN *ET AL.*

APPLICATION NO.: 10/695,419

FILED: OCTOBER 27, 2003

FOR: **APPARATUS AND METHOD FOR
ELECTROLYTICALLY DEPOSITING
COPPER ON A SEMICONDUCTOR
WORKPIECE**

EXAMINER: THOMAS H. PARSONS

ART UNIT: 1745

CONF. NO: 4483

Amendment Under 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated September 8, 2004 in the above-identified application. Please amend the application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Drawings are reflected in an attached replacement sheet and are discussed on page 16.

Amendments to the Claims are reflected in the listing of claims beginning on page 17.